



PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Takashi AOKI et al.

Group Art Unit: 2851

Application No.: 10/030,822

Examiner: R. Fuller

Filed: January 16, 2002

Docket No.: 111673

For: EXPOSURE METHOD AND SYSTEM

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the August 24, 2004 Office Action, the shortened statutory period for reply being extended by the attached Petition for Extension of Time, please consider the following:

Amendments to the Claims as reflected in the listing of claims; and

Remarks.